Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/634,868	TOMITSUKA ET AL.		
Examiner	Art Unit		
Michael A. Friedhofer	2832		

	SEARCHED				
Class	Subclass	Date	Examiner		
200	5a,6a,511, 512,516, 517	12/9/2005	MAF		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
200	5a,6a,511	12/9/2005	MAF	
200	512,516	12/9/2005	MAF	
200	517	12/9/2005	MAF	

	STRATEGY	
	DATE	EXMR
interference search: see search	12/9/2005	MAF
history	12/9/2005	IVIAL
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